

Patent Center

- < Back to home
- Application Data
- Documents & Transactions
- Continuity
- Patent Term Adjustment
- Foreign Priority
- Fee Payment History
- Address & Attorney/Agent Information
- Supplemental Content
- Assignments
- Display References

08/223,739 | 160246: METHOD OF DEPOSITING A GALLIUM NITRIDE-BASED III-V GROUP COMPOUND SEMICONDUCTOR CRYSTAL LAYER

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Application #	Attorney Docket #	Patent #	Status	Filing or 371 (c) date
08/223,739	160246	5,433,169 ↗ Issued - 07/18/1995	Patent Expired Due to NonPayment of Maintenance Fees Under 37 CFR 1.362 - 08/13/2007	04/06/1994

IFW and transaction history

Documents Transactions

Date	Transaction Description
08/13/2007	Expire Patent
04/24/2006	Correspondence Address Change
07/18/1995	Recordation of Patent Grant Mailed
06/12/1995	Issue Notification Mailed
05/04/1995	Issue Fee Payment Verified
02/21/1995	Mail Notice of Allowance
02/21/1995	Notice of Allowance Data Verification Completed
06/15/1994	Information Disclosure Statement (IDS) Filed
06/15/1994	Information Disclosure Statement (IDS) Filed
05/24/1994	Case Docketed to Examiner in GAU
05/20/1994	Transfer Inquiry
05/09/1994	Application Captured on Microfilm